

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re Applicant:

Boaz RAN et al.



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Serial No.: 10/540,940

Filed: June 23, 2005

Group Art Unit: 2886

For: SURFACE PLASMON RESONANCE
SENSOR

Attorney
Docket: 36317

Examiner: Michael Patrick STAFIRA

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

Enclosed is a PTO Form 1449 which lists citations which may be material to the patentability and examination of the above identified application. Also enclosed are copies of the references cited. These are submitted in compliance with the duty of disclosure defined in 37 CFR 1.56. The Examiner is requested to make these citations of official record in this application.

This Supplemental Information Disclosure Statement under 37 CFR 1.56 is not to be construed as a representation that a search has been made, that additional matter which is material to the examination of this application does not exist, or that any or more of these citations constitutes prior art.

Respectfully submitted,

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Dated: April 29, 2008